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Application/Control No.	Applicant(s)/Pater Reexamination	Applicant(s)/Patent under Reexamination	
10/524,904	SHIRAKAMI ET	AL.	
Examiner	Art Unit		
Noah Kamen	3747		

SEARCHED					
Class	Subclass	Date	Examiner		
123	73R	2/13/2006	18		
	73A				
	73PP				
	65A				
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
-	DATE	EXMR	
EAST	2/13/2006	NX	

